## IN THE CLAIMS:

The following claims will replace all prior versions of claims in this application.

- 1. (Currently Amended) A method for determining a deviation of at least one regulating variable on a chip removal machine with a mechanical drive for a tool or a workpiece or a combination thereof, regulated by a control system, wherein the regulation comprises a plurality of values C, X, Z of at least three spatial axes c, x, z for the control system and for the drive, and the values C, X, Z have a functional relation  $f_{bi}$  with the axes c, x, z, comprising the steps of:
- a) preparing a protocol from a plurality of control system actual values detected by measuring means or selected drive actual values or combinations thereof,
- b) calculating a control system nominal value  $Z_{bi,s} = f_{bi} (C_{p,s}, X_{p,s})$  or a drive nominal value  $Z_{bi,a} = f_{bi} (C_{p,a}, X_{p,a})$  or a combination thereof at least in relation to the z-axis, [[and]]
- c) calculating a control system differential value  $D_{z,s} = Z_{p,s} Z_{bi,s}$  or a drive differential value  $D_{z,a} = Z_{p,a} Z_{bi,a}$  or combinations thereof at least in relation to the z-axis; and[[.]]
- d) determining for at least for the drive and the z-axis a contouring differential value  $D_{z,a}^{\phi} = Z_{p,a} Z_{bi,a}^{\phi}$  with  $Z_{bi,a}^{\phi} = f_{bi}$  ( $C_{p,a} + \Delta \phi$ ,  $X_{p,a}$ ), where the value  $\Delta \phi$  corresponds to a phase shift of the c-axis, which results in a torsion of generated lens contour.

## 2. (Canceled)

- 3. (Currently Amended) The method according to claim [[2]]  $\underline{1}$ , wherein the phase shift  $\Delta \phi$  is between 0.5° and 3°, and the determination of  $Z_{bi,a}^{\phi}$  is done between +  $\Delta \phi$  and - $\Delta \phi$  with an increment between 0.05° and 0.2°.
- 4. (Currently Amended) The method according to claim **[[2]]** 1, wherein one computes, at least from the differential values  $D_{z,s}$ ,  $D_{z,a}$  or the contouring differential value  $D_{z,a}^{\phi}$  or a combination thereof at least for the z-axis, one peak-to-valley value for the control system

$$D_{z,s,ptv} = D_{z,s,max} - D_{z,s,min}$$

and peak-to-valley values for the drive

$$D_{z,a,ptv} = D_{z,a,max} - D_{z,a,min}$$

$$D_{z,a}^{\varphi}_{ptv} = D_{z,a,max}^{\varphi} - D_{z,a,min}^{\varphi}$$
,

where  $D_{z,s/a,min}$  corresponds to minimum and  $D_{z,s/a,max}$  to maximum differential values of respective measurements and  $D_{z,a,max}^{\ \phi}$ ,  $D_{z,a,min}^{\ \phi}$  corresponds to a respective position  $\phi$ ,  $+\Delta\phi$  and  $-\Delta\phi$  of the c-axis, taking into account  $+/-\Delta\phi$ .

5. (Previously Presented) The method according to claim 1, wherein one determines an error differential value

$$D_{z,a}^{f} = Z_{p,a} - Z_{bi,a}^{f}$$

with

$$Z_{bi,a}^{f} = f_{bi} (C_{p,s}, X_{p,s})$$

at least for the drive and at least in relation to the z-axis.

- 6. (Previously Presented) The method according to claim 1, wherein the function  $f_{bi}$  is a 3D bicubic surface spline or a spiral spline or a combination thereof.
- 7. (Previously Presented) The method according to claim 4, wherein the differential values  $D_{z,a}$ ,  $D_{z,s}$ , the contouring differential value  $D_{z,a}^{\phi}$ , the respective peak-to-valley values  $D_{z,s,ptv}$ ,  $D_{z,a,ptv}$ ,  $D_{z,a}^{\phi}_{ptv}$  or the actual values  $Z_{p,s}$ ,  $Z_{p,a}$  of at least the z-axis or combinations thereof are represented, and at least one or more of the representation of  $D_{z,s,ptv}$ ,  $D_{z,a,ptv}$ , and  $D_{z,a}^{\phi}_{ptv}$  is done with the smallest possible peak-to-valley value.
- 8. (Previously Presented) The method according to claim 4, wherein the size or the deviation or a combination thereof of at least the peak-to-valley values  $D_{z,s,ptv}$ ,  $D_{z,a}^{\varphi}$  or the actual values  $Z_{p,s}$ ,  $Z_{p,a}$  or a combination thereof is represented in terms of a respective workpiece position.
- 9. (Previously Presented) The method according to claim 7, wherein one distinguishes optically between negative and positive values when representing the

differential value or the contouring differential values  $D_{z,a}$ ,  $D_{z,a}$ ,  $D_{z,a}$  or optically in terms of the magnitude of the values or combinations thereof.

- 10. (Previously Presented) The method according to claim 7, wherein positive or negative or a combination thereof differential values or contouring differential values  $D_{z,a}$ ,  $D_{z,s}$ ,  $D_{z,a}^{\varphi}$  or a combination thereof are optically graduated by different color tones in terms of their magnitude or by different color tone intensities in terms of the magnitude of the values or a combination thereof.
- 11. (Previously Presented) The method according to claim 7, wherein one provides for a superimposed representation of one or more of the differential value and the contouring differential values  $D_{z,a}$ ,  $D_{z,s}$ ,  $D_{z,a}^{\phi}$  and the actual values  $Z_{p,s}$ ,  $Z_{p,a}$ , the respective scale being different for the two values.
- 12. (Previously Presented) The method according to claim 1, wherein one calculates, for one or more other axes x, c, nominal values  $C_{bi}$ ,  $X_{bi}$ , differential values  $D_{x/c,a}$ ,  $D_{x/c,a}$ ,  $D_{x/c,s}$ , peak-to-valley values  $D_{x/c,a,ptv}$ ,  $D_{x/c,a}^{\phi}$  ptv,  $D_{x/c,s,ptv}$ ,  $D_{x/c,s}^{\phi}$  ptv, one or more of error differential values  $D_{x/c,a}^{f}$ ,  $D_{x/c,a}^{f}$  and contouring differential values  $D_{x/c,s}^{\phi}$ ,  $D_{x/c,a}^{\phi}$ , or a combination thereof for the control system or for the drive or a combination thereof.
- 13. (Currently Amended) The method according to claim [[2]]  $\underline{1}$ , wherein one provides for a correction cut, in addition to a main cut and an optional precision cut during a chip removal machining of the workpiece, at least making use of the differential values  $D_{z,a}$ ,  $D_{z,s}$ ,  $D_{z,a}^{\varphi}$ .
- 14. (Previously Presented) The method for a chip removal machine for the production of optical lenses from plastic according to claim 1.
- 15. (Previously Presented) The method according to claim 1, wherein one converts the values C, X, Z of the axes c, x, z into a Cartesian system of coordinates or into a polar system of coordinates.

- 16. (Previously Presented) The method according to claim 1, wherein one starts from a theoretical cutting point of an ideal point-like tool and convert the values C, X, Z of the axes c, x, z for use of a circular carbide tip, with the circular carbide tip having a center point corresponding to the theoretical cutting point.
- 17. (Currently Amended) The method according to claim [[2]]  $\underline{1}$ , wherein one uses at least one differential value  $D_{z,a}$  or one contouring differential value  $D_{z,a}^{\phi}$  or a combination thereof as an exclusion criterion for the control system's actual values ( $C_{p,s}$ ,  $X_{p,s}$ ,  $Z_{p,s}$ ) or as an adjustment criterion or a combination thereof for various machine parameters and the machine's control system.
- 18. (Currently Amended) A chip removal machine comprising: a mechanical drive for a tool or a workpiece or a combination thereof, regulated by a control system, wherein the regulation comprises a plurality of values C, X, Z of at least three spatial axes c, x, z for the control system and for the drive, wherein the values C, X, Z have a functional relation  $f_{bi}$  with the axes c, x, z, wherein the control system determines the deviation of the regulating variables by a) preparing a protocol from a plurality of control system actual values ( $C_{p,s}$ ,  $X_{p,s}$ ,  $Z_{p,s}$ ) detected by measuring means or selected drive actual values ( $C_{p,a}$ ,  $X_{p,a}$ ,  $Z_{p,a}$ ) or a combination thereof,
- b) calculating a control system nominal value  $Z_{bi,s} = f_{bi}$  ( $C_{p,s}$ ,  $X_{p,s}$ ) or a drive nominal value  $Z_{bi,a} = f_{bi}$  ( $C_{p,a}$ ,  $X_{p,a}$ ) or a combination thereof at least in relation to the z-axis, [[and]]
- c) calculating a control system differential value  $D_{z,s} = Z_{p,s} Z_{bi,s}$  or a drive differential value  $D_{z,a} = Z_{p,a} Z_{bi,a}$  or combinations thereof at least in relation to the z-axis, and [[.]]
- d) determining for at least for the drive and the z-axis a contouring differential value  $D_{z,a}^{\phi} = Z_{p,a} Z_{bi,a}^{\phi}$  with  $Z_{bi,a}^{\phi} = f_{bi}$  ( $C_{p,a} + \Delta \phi$ ,  $X_{p,a}$ ), where the value  $\Delta \phi$  corresponds to a phase shift of the c-axis, which results in a torsion of generated lens contour.

19. (Previously Presented) The chip removal machine according to claim 18, wherein an output unit is provided for a representation of the values, and wherein the function  $f_{bi}$  is a 3D bicubic surface spline or a spiral spline or a combination thereof.